Supporting Information

Covalent Organic Framework Films through Electrophoretic Deposition - Creating Efficient Morphologies for Catalysis

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Deposition of BDT-ETTA COF on FTO, ITO and titanium foil

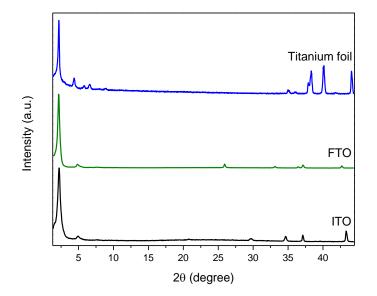


Figure S1: Deposition of BDT-ETTA COF on different conducting surfaces, namely titanium foil, glass coated with FTO and glass coated with ITO. All depositions were carried out using 10 mL of BDT-ETTA COF suspension in ethyl acetate at 900 V for 2 min.

Deposition of BDT-ETTA COF in anisole, ethyl acetate and toluene

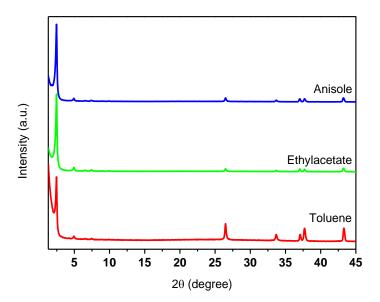


Figure S2: Deposition of BDT-ETTA COF from different solvents, namely anisole, ethyl acetate and toluene. All depositions were carried out using 10 mL of the respective BDT-ETTA COF suspension at 900 V for 2 min.

DLS Data for ultrasound treated BDT-ETTA COF

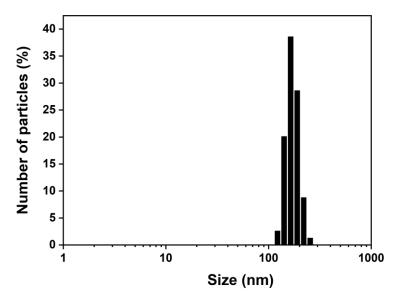


Figure S3: Particle size distribution of BDT-ETTA COF after the ultrasonic milling process.

Transmission electron micrographs

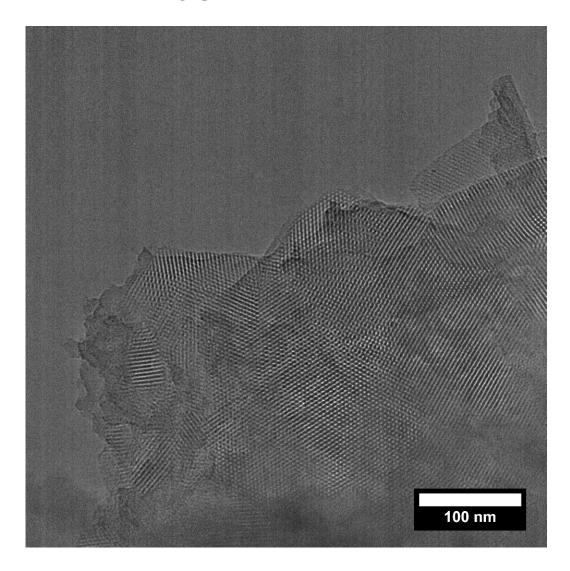


Figure S4: TEM image of deposited BDT-ETTA COF particles after the ultrasonic milling process.

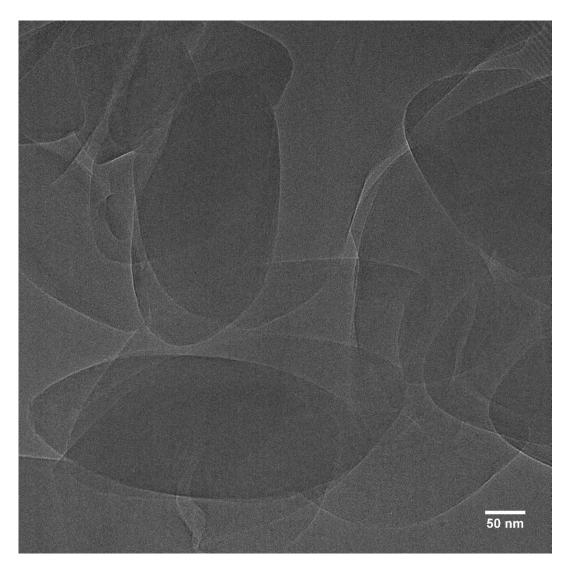


Figure S5: TEM image of deposited COF-300 particles.

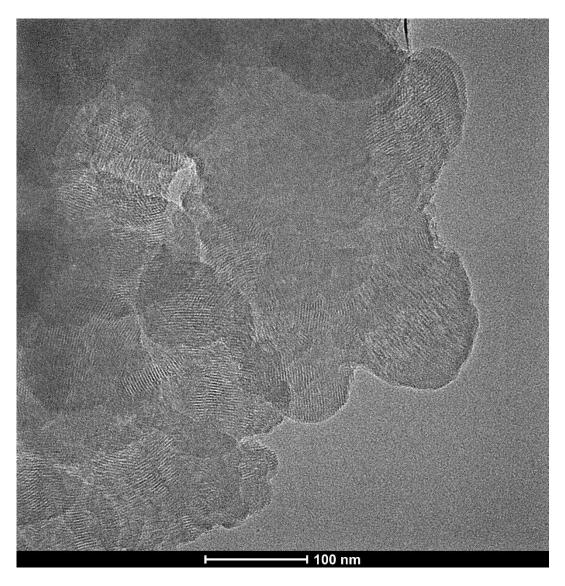


Figure S6: TEM image of deposited COF-5.

COF EPD film physisorption

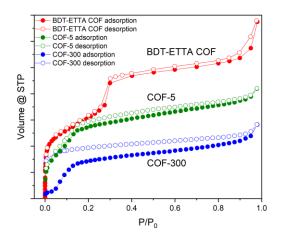


Figure S7: Nitrogen physisorption isotherms of scratched-off powder from the respective COF EPD films. Due to the low mass of the scratched-off powders, quantitative nitrogen uptake could not be accurately determined.

Fourier-transform infrared spectroscopy

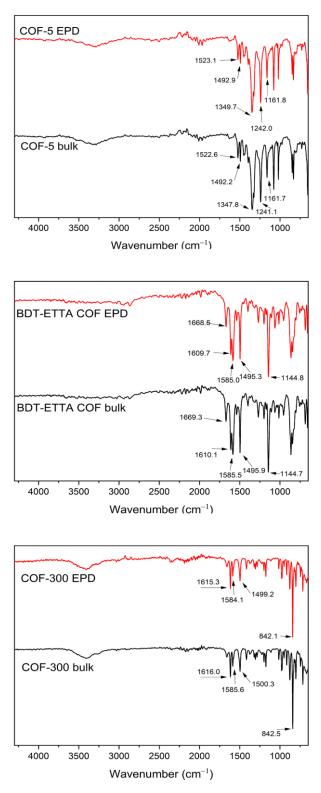


Figure S8: FT-IR spectra of the as-synthesized bulk material and as scratched-off EPD film materials. In all three cases IR vibrations are preserved. This indicates that no chemical degradation occurred during the EPD process.

BDT-ETTA COF time-dependent thickness plot

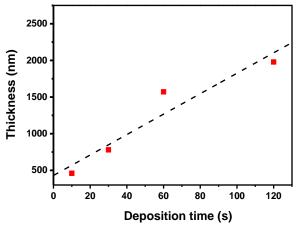


Figure S9: Time-dependent thickness plot of BDT-ETTA COF deposited from ethyl acetate at 900 V. Thicknesses obtained from SEM cross-sections.

Voltage dependent deposition of BDT-ETTA COF

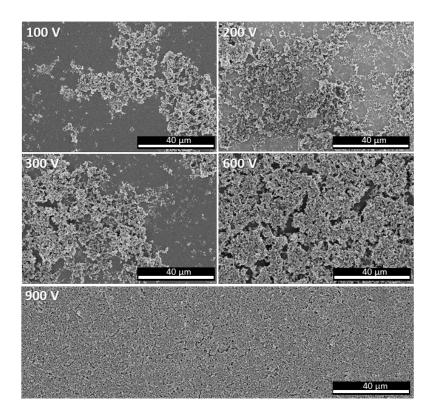


Figure S10: SEM top-view images of BDT-ETTA COF deposited at different voltages for 2 min from ethyl acetate.

Mass-dependent deposition of COF-300

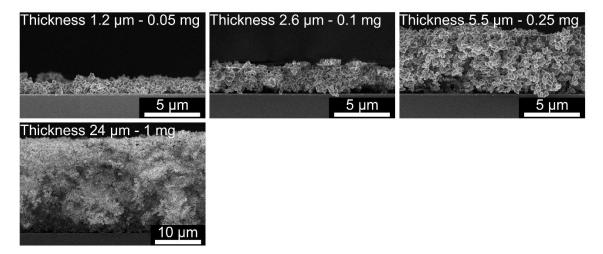
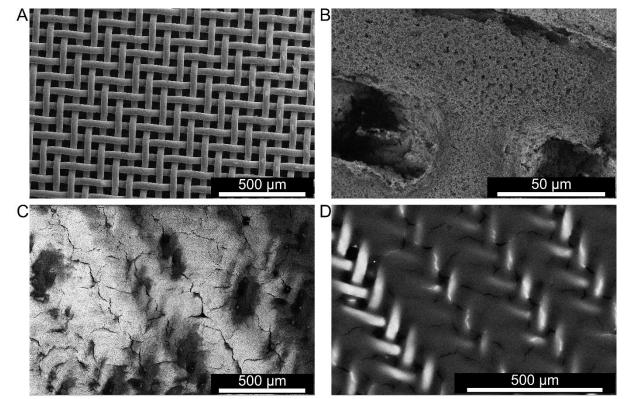


Figure S11: SEM cross-section images of depositions of COF-300 using different masses in 10 mL suspension and the resulting film thicknesses. Depositions were carried out at 900 V for 2 min from ethyl acetate.

Large area deposition of BDT-ETTA COF



Figure S12: Photograph of an EPD of BDT-ETTA COF on 5 cm \times 5 cm electrode area as well as a 1 cm \times 1 cm film. Both depositions were carried out on FTO at 900 V for 2 min.



SEM Micrographs of BDT-ETTA COF deposited on a porous mesh

Figure S13: SEM top view micrographs of BDT-ETTA COF depositions on a porous steel mesh (mesh size 270). (A) Image of the bare mesh prior to deposition. (B) High magnification of BDT-ETTA COF particles deposited on the mesh. (C) Deposition of BDT-ETTA COF in high concentration on a steel mesh, revealing the complete coverage of the pores. (D) Corresponding back-scattered electron micrograph at 30 kV acceleration voltage, revealing the underlying mesh structure.

Thickness dependent PEC current measurements and chronoamperometry

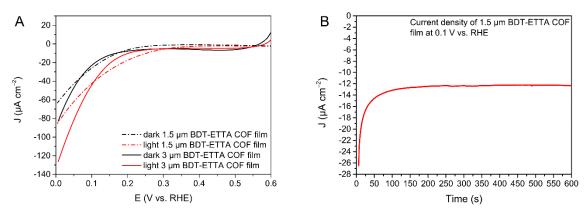


Figure S14: (A) Thickness dependent PEC linear sweep voltammograms of electrodes coated with BDT-ETTA COF. Illumination at AM1.5G. (B) Chronoamperometric current density measurement of BDT-ETTA COF under illumination.

Stability of BDT-ETTA COF after PEC catalysis

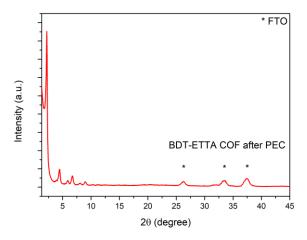


Figure S15: Stability of BDT-ETTA COF after 30 minutes of chopped illumination at 0.1 V vs. RHE.

Pt nanoparticles size characterization

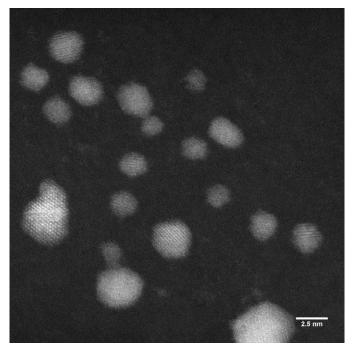


Figure S16: TEM micrograph of Pt nanoparticles after lyophilization.

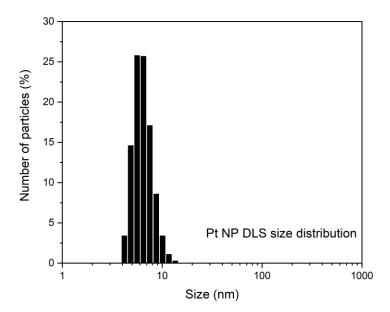


Figure S17: DLS profile of Pt nanoparticles after lyophilization.